

**Search Notes**

Application/Control No.

10/666,470

Applicant(s)/Patent under  
ReexaminationVISWESWARIAH,  
CHANDRAMOULI

Examiner

Sun J. Lin

Art Unit

2825

**SEARCHED**

| Class | Subclass | Date       | Examiner |
|-------|----------|------------|----------|
| 716   | 6        | 10/14/2005 | JSL      |
| 716   | 5        | 10/14/2005 | JSL      |
| 716   | 4        | 10/14/2005 | JSL      |
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**INTERFERENCE SEARCHED**

| Class | Subclass | Date | Examiner |
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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|  | DATE       | EXMR |
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| EAST<br>[USPAT;US-<br>PGPUB;EPO;JPO;DERWENT;IBM_T<br>DB] | 10/14/2005 | JSL  |
| EAST<br>[USPAT;US-<br>PGPUB;EPO;JPO;DERWENT;IBM_T<br>DB] | 10/17/2005 | JSL  |
| IEEE   | 10/14/2005 | JSL  |
| IEEE   | 10/17/2005 | JSL  |
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